



12.63479

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re U.S. Patent Application)

Applicant: Hongyong Zhang)

Serial No.: 09/468,489)

Filing Date: December 20, 1999)

For: THIN FILM TRANSISTOR HAVING
LIGHTLY AND HEAVILY DOPED
SOURCE/DRAIN REGIONS AND ITS
MANUFACTURE)

Art Unit: 2814)

Examiner: Quach, T.)

I hereby certify that this paper is being deposited with
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No. 47,954

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Assistant Commissioner for Patents
Washington, D.C. 20231

Dear Sir:

Please direct all future correspondence concerning the above-identified
Application to the following address:

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Respectfully submitted,

GREER, BURNS & CRAIN, LTD.

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January 7, 2002

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